



FORM PTO-1449/A and B (Modified) INFORMATION DISCLOSURE STATEMENT BY APPLICANT				APPLICATION NO.: 09/808,745	ATTY. DOCKET NO.: H0498.70135US00
				FILING DATE: March 15, 2001	CONFIRMATION NO.: 4346
				APPLICANT: Emanuele Ostuni et al.	
				GROUP ART UNIT: 1651	EXAMINER: Deborah K. Ware
Sheet 1 of 2					

U.S. PATENT DOCUMENTS

Examiner's Initials	Cite No.	U.S. Patent Document		Name of Patentee or Applicant of Cited Document	Date of Publication or of issue of Cited Document MM-DD-YYYY
		Number	Kind Code		

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OTHER ART – NON PATENT LITERATURE DOCUMENTS

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<i>dkw</i>		Z. Bao et al., "High-Performance Plastic Transistors Fabricated by Printing Techniques," <u>Chem. Mater.</u> , (1997), Vol. 9, pgs. 1299-1301.	
<i>dkw</i>		G.J. Burger et al., "High-resolution shadow-mask patterning in deep holes and its application to an electrical wafer feed-through," <u>Sensors and Actuators</u> , (1996), A54:669-673.	
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EXAMINE R

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11-10-04

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FORM PTO-1449/A and B (Modified)

AUG 30 2004 151
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O I P E S C 152

**INFORMATION DISCLOSURE
STATEMENT BY APPLICANT**

Sheet 2 of 2

APPLICATION NO.: 09/808,745 ATTY. DOCKET NO.: H0498.70135US00

FILING DATE: March 15, 2001 CONFIRMATION NO.: 4346

APPLICANT: Emanuele Ostuni et al.

GROUP ART UNIT: 1651 EXAMINER: Deborah K. Ware

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<i>Dew</i>		S. Leppavuori et al., "A novel thick-film technique, gravure offset printing, for the realization of fine-line sensor structures," <i>Sensors and Actuators</i> , (1994), A 41-42, pgs. 593-596.	
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